Application Number:	100	10615842					
Filing Date:	10-	10-Jul-2003					
Title of invention:	DE	DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS					
First Named Inventor/Applicant Name:	Soci	Soojin Oh					
Filer:	Jef	Jeffrey L. Wilson/Laura Pleasants					
Attorney Docket Number:	10	1032566-000066					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fee	s						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1740